

2 / IDS
E. Hillis
4-18-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Toshikazu INOUE et al.**

Serial Number: **Not Yet Assigned**

Filed: **December 29, 1999**

For: **SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
THE SAME**

PATENT



INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

December 29, 1999

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 01-2340.

Respectfully submitted,
ARMSTRONG, WESTERMAN, HATTORI
McLELAND & NAUGHTON

Le-Nhung McLeland
Reg. No. 31,541

Atty. Docket No.: 991493
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
Tel: (202) 659-2930
Fax: (202) 887-0357
LNM/yap
Enclosures: PTO-1449; References (5).